



TRANSMITTAL OF FORMAL DRAWINGS

TEW
Docket No.
FIS920040027US1 (17404)

Inventor: Application Of: Kevin K. Chan, et al.

| Application No. | Filing Date | Confirmation No. | Examiner | Customer No. | Group Art Unit |
|-----------------|---------------|------------------|------------|--------------|----------------|
| 10/710,737 | July 30, 2004 | Unassigned | Unassigned | 23389 | Unassigned |

Invention: **CHEMICAL TREATMENT TO RETARD DIFFUSION IN A SEMICONDUCTOR OVERLAYER**

Address to:
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Transmitted herewith are:

4 sheets of formal drawing(s) for this application.

☒ Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c).


Signature

Leslie S. Szivos, Ph.D.
Registration No. 39,394

Dated: February 4, 2005

I certify that this document and attached formal drawings
are being deposited on 02/05/05 with the U.S.
Postal Service as first class mail under 37 C.F.R. 1.8 and
addressed to the Commissioner for Patents, P.O. Box 1450,
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Signature of Person Mailing Correspondence

Leslie S. Szivos, Ph.D.

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